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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 213.002-D1-US)

In the Application of: Ye et al.)

Serial No: 10/646,313)

Filed: August 22, 2003)

Title: System and Method for Lithography)
Process Monitoring and Control)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

) U.S. Patent 6,806,456

I hereby certify that this correspondence
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Date

Michiko Sites

(name of person signing certificate)

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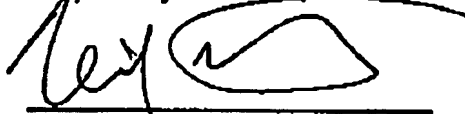
Signature

NOTIFICATION OF CHANGE OF SMALL ENTITY STATUS

Dear Sir:

Pursuant to 37 CFR §1.27(g)(2), the above-referenced patent/application is no longer entitled to small entity status.

Respectfully submitted,



Date: April 19, 2007

Neil A. Steinberg, Reg. No. 34,735
Telephone No. 650-968-8079